

2812

PATENT APPLICATION

0862.022541

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MASATAKA ITO

Application No.: 10/091,461

Filed: March 7, 2002

For: SOI SUBSTRATE, ANNEALING  
METHOD THEREFOR,  
SEMICONDUCTOR DEVICE  
HAVING THE SOI SUBSTRATE,  
AND METHOD OF  
MANUFACTURING THE SAME

Examiner: S. Isaac

Group Art Unit: 2812

August 14, 2002

TC 2800 MAIL ROOM

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8-27-02  
R. S. Isaac

Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to U.S. Patent 6,407,367 listed on the enclosed Form PTO-1449, a copy of which is enclosed.

The subject application has not received a final action or a Notice of Allowance. Accordingly, this Information Disclosure Statement is timely filed under 37 C.F.R. § 1.97(c) and is accompanied by the \$180.00 fee specified in 37 C.F.R. § 1.17(p). The Examiner is urged to study this information in its entirety and to form an independent determination of the materiality of the information to the claimed invention. Additionally, the examiner is requested to indicate

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that this information has been considered by initialing the appropriate portion of Form PTO-1449.

Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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